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## Correction: Recent advances in microfluidic-based electroporation techniques for cell membranes

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Correction for ‘Recent advances in microfluidic-based electroporation techniques for cell membranes’ by Fei Wang *et al.*, *Lab Chip*, 2022, 22, 2624–2646, <https://doi.org/10.1039/D2LC00122E>.

The authors regret that there was an error in the caption for Fig. 6C on page 2635 of the original article. The text originally read, “Reprinted with permission from ref. 12. Copyright 2019, *Bioelectrochemistry*”. This sentence should read “Reprinted with permission from ref. 12. Copyright 2020, *Bioelectrochemistry*”.

There was an error in the caption for Fig. 11B on page 2642 of the original article. The text originally read “Reprinted with permission from ref. 21. Copyright 2016, *Nanoscale*”. This sentence should read “Reprinted with permission from ref. 28. Copyright 2016, *Nanoscale*”.

There was an error in the caption of Fig. 11C on page 2642 of the original article. The original text read “Reprinted with permission from ref. 28. Copyright 2020, *Microsystems & Nanoengineering*”. This sentence should read “Reprinted with permission from ref. 21. Copyright 2020, *Microsystems & Nanoengineering*”.

There was also an error in the caption of Fig. 10A on page 2640 of the original article. The original text read, “Copyright 2019, *Journal of Micromachines*”. This sentence should read “Copyright 2019, *Micromachines*”.

Finally, there were errors in Section 5.4 Complementary electroporation system: the citation to “Fig. 11C” should be a citation to “Fig. 11B”, and the citation to “Fig. 11B” should be a citation to “Fig. 11C”.

The Royal Society of Chemistry apologises for these errors and any consequent inconvenience to authors and readers.

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